

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of MAJIMA et al.

Application No. 09/890,550

Filed: January 14, 2002

For: POROUS SILICON CARBIDE SINTER AND SILICON CARBIDE-METAL  
COMPOSITE THAT ARE OPTIMAL FOR A WAFER GRINDER TABLERECEIVED  
CENTRAL FAX CENTER  
APR 28 2005AMENDMENTCERTIFICATE OF TRANSMISSION/MAILING

I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, Alexandria, VA 22313-1450 on 4-28-05.

  
Mark D. Passler Reg. No. 40,764

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENTS

This is in response to the Office Action dated October 28, 2004. Please amend the above-identified application as follows:

**Amendments to the claims begin on page 2 of this paper.**

**Remarks/arguments begin on page 5 of this paper.**

(WP231692:1)